Special Issue

Potentials of 2D Materials for Emerging Electronic Devices

Message from the Guest Editor

We are pleased to invite you to contribute to this Special Issue, which focuses on the **sensing potential of 2D materials for modern devices**. Two-dimensional materials have ushered in a new era in sensor technology, owing to their exceptional electrical conductivity, high surface-to-volume ratio, mechanical flexibility, and tunable band structures. These properties make them uniquely suited for the development of next-generation sensors with ultra-high sensitivity, fast response times, and multifunctionality. This Special Issue aims at bringing together recent advancements in the synthesis, functionalization, and device integration of 2D materials—such as **graphene, transition metal dichalcogenides (TMDs), black phosphorus, MXenes**, and their van der Waals heterostructures—for high-performance sensing applications. Topics of interest include, but are not limited to, **chemical, biological, optical, and physical sensors**, as well as innovations in fabrication methods, signal amplification strategies, and hybrid systems. We especially encourage submissions that address challenges related to **scalability, selectivity, low power operation, and integration with IoT, AI, and wearable platforms**.

Guest Editor

Prof. Dr. Ghulam Dastgeer
Department of Physics and Astronomy, Sejong University, Neungdong-ro 209, Gwangjin-gu, Seoul 05006, Republic of Korea

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Micromachines
Editorial Office
MDPI, Grosspeteranlage 5
4052 Basel, Switzerland
Tel: +41 61 683 77 34
micromachines@mdpi.com

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Editor-in-Chief

Prof. Dr. Nam-Trung Nguyen
Queensland Quantum and Advanced Technologies Research Institute, Griffith University, West Creek Road, Nathan, QLD 4111, Australia

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